	The as-depos	ited nanostru	ctures			Б	
Specimen designation	Height (CNCs) + Height (CNFs) (nm)	Base diameter (nm)	Number density (G/inch ²)	Morphology	I _D /I _G	$E_{turn-on}$ (V/ μ m) at 1mA/cm ²	β
A1				Trace deposition (Fig. 4-1(a))	1.91		
A2	109+0	66	44	CNCs (Fig. 4-1(b))	1.77		
A3	178+0	84	34	CNCs (Fig. 4-1(c))	1.85		
A4	341+0	161	28	CNCs (Fig. 4-1(d))	1.77	~0.63	~70205
A5	393+91	174	22	CNFs on CNCs (Fig. 4-1(e))	1.76	~0.39	~70705
A6	894+x	383	8	Dense CNFs on CNCs (Fig. 4-1(f))	2.15		
B1				Trace deposition (Fig. 4-2(a))	1.76		
B2	50+0	49	69 S	CNCs (Fig. 4-2(b))	1.88		
B3	193+0	121	33	CNCs (Fig. 4-2(c))	1.86		
B4	400+0	160	29	CNCs (Fig. 4-2(d))	1.72	~0.53	~75595
B5	637+147	287	18	Trace CNFs on CNCs (Fig. 4-2(e))	1.65	~0.24	~21389
B6	1061+x	295	Х	Dense CNFs on CNCs (Fig. 4-2(f))	1.81		
C1				Trace deposition (Fig. 4-3(a))	1.82		
C2	83+0	42	92.5	CNCs (Fig. 4-3(b))	1.93		
C3	144+45	73	75	CNFs on CNCs (Fig. 4-3(c))	1.65	~0.56	~20095
C4	547+200	157	38	CNFs on CNCs (Fig. 4-3(d))	1.59	~0.18	~75605
C5	843+303	268	22	CNFs on CNCs (Fig. 4-3(e))	1.38	~0.39	~30423
C6	1400+x	406	X	Trace CNFs on damaged CNCs (Fig. 4-3(f))	2.10		

Table 4-1 Features of the nanostructures and their properties (for different deposition times)

---: No values could be observed. ; x: The values could not be estimated.

	The as-deposited	carbon nanos				
Specimen	Height (CNCs) +	Base	Number	Monnhology	тл	
designation	Height (CNFs)	diameter	density	Morphology	I _D /I _G	
	(nm)	(nm)	(G/inch ²)			
A 7	916,116	152	24	CNFs on CNCs	1 75	
A/	810+110	155	24	(Fig.4-10 (a) \ (b))	1.75	
4.9	260 - 142	102	28	CNFs on CNCs	1.69	
Að	309+143	105	28	(Fig.4-10 (c) \ (d))		
4.0	0.78	41		Short CNFs no CNCs	1 72	
A9	0 + / 8	41	Х	(Fig.4-10 (e) \ (f))	1.75	
	350+166	121	42.5	CNFs on CNCs	1.61	
В/				(Fig.4-11 (a) \ (b))	1.01	
DΩ	166 191	04	17.5	CNFs on CNCs	1 (0	
Dð	100+181	94 47.5		(Fig.4-11 (c) \ (d))	1.08	
DO	0+134	1120	20	Short CNFs no CNCs	1 75	
В9			SIA	(Fig.4-11 (e) \ (f))	1.75	
C7	516,200	147 33		CNFs on CNCs	1.39	
C/	510+290			(Fig.4-12 (a) \ (b))		
C8	224 1107	109 47		CNFs on CNCs	1.40	
	554+1197			(Fig.4-12 (c) \ (d))	1.40	
CO	70			Catalyst-embedded carbon film	1 59	
69				(Fig.4-12 (e) \ (f))	1.38	

 Table 4-2 Features of the carbon nanostructures and their properties (for different working pressures)

x: The values could not be estimated.

	The as-deposited carbon nanostructures	
Specimen		I_D/I_G
designation	Morphology	
E1	CNCs (Fig. 4-13 (a))	1.88
E2	Carbon film on CNCs (Fig. 4-13 (b))	1.78
E3	Carbon film on CNCs and trace CNTs growth (Fig. 4-13 (c))	1.65
E4	Tubule-like CNTs and catalyst-embedded carbon film (Fig. 4-13 (d))	1.52
E5	CNTs and catalyst-embedded carbon film (Fig. 4-13 (e))	0.66
E6	CNTs and catalyst-embedded carbon film (Fig. 4-13 (f))	1.43
E7	CNTs and fewer catalyst-embedded carbon film (Fig. 4-13 (g))	1.26
E8	Spaghetti-like CNTs (Fig. 4-13 (h))	1.06
F1	CNCs (Fig. 4-14 (a))	1.99
F2	Carbon film on CNCs (Fig. 4-14 (b))	1.76
F3	Carbon film on CNCs and trace CNTs growth (Fig. 4-14 (c))	1.20
F4	Tubule-like CNTs and catalyst-embedded carbon film (Fig. 4-14 (d))	1.06
F5	CNTs and catalyst-embedded carbon film (Fig. 4-14 (e))	0.79
F6	CNTs and catalyst-embedded carbon film (Fig. 4-14 (f))	1.24
F7	CNTs and fewer catalyst-embedded carbon film (Fig. 4-14 (g))	1.21
F8	Spaghetti-like CNTs (Fig. 4-14 (h))	1.31
G1	CNCs (Fig. 4-15 (a))	2.03
G2	Carbon film on CNCs (Fig. 4-15 (b))	1.89
G3	Carbon film on shorter CNCs (Fig. 4-15 (c))	1.68
G4	Carbon film on catalysts (Fig. 4-15 (d))	1.49
G5	CNTs and catalyst-embedded carbon film (Fig. 4-15 (e))	0.91
G6	CNTs and catalyst-embedded carbon film (Fig. 4-15 (f))	1.19
G7	CNTs and catalyst-embedded carbon film (Fig. 4-15 (g))	1.20
G8	Spaghetti-like CNTs (Fig. 4-15 (h))	1.32

Table 4-3 Features of the carbon nanostructures and their properties (for different H_2/CH_4 flow ratios)

Specimen	The as-deposited carbon nanostructures		E _{turn-on}	
designatio n	Morphology		(V/μm) at 1 mA/cm ²	β
H1	Carbon film (Fig. 4-16 (a))	2.03		
H2	Carbon film and trace CNTs (Fig. 4-16 (b))	2.00		
H3	Fewer carbon film and short CNTs (Fig. 4-16 (c))	1.83		
H4	Catalyst-embedded carbon film and CNTs (Fig. 4-16 (s))	1.72		
H5	Bamboo-like CNTs (Fig. 4-16 (e))	1.01		
H6	Catalyst-embedded carbon film and CNTs (Fig. 4-16 (f))	1.78		
H7	Catalyst-embedded carbon film (Fig. 4-16 (g))	2.55		
I1	Carbon film (Fig. 4-17 (a))	2.07		
I2	Catalyst-embedded carbon film (Fig. 4-17 (b))	1.72		
I3	Catalyst-embedded carbon film and CNTs (Fig. 4-17 (c))	1.77		
I4	Short CNTs (Fig. 4-17 (d))	1.73	~7.76	
15	Bamboo-like CNTs (Fig. 4-17 (e))	1.66	~5.00	~912
I6	Well-aligned CNTs (Fig. 4-17 (f))	1.66	~5.61	~841
I7	Catalyst -embedded carbon film and spaghetti-like CNTs (Fig. 4-17 (g)))	1.81	~9.98	
J1	Carbon film (Fig. 4-18 (a))	2.02		
J2	Carbon film and trace CNTs growth (Fig. 4-18 (b))	1.89		
J3	Carbon film and CNTs (Fig. 4-18 (c))	1.81		
J 4	Catalyst-embedded carbon film and CNTs (Fig. 4-18 (d))	1.76		
J5	Catalyst-embedded carbon film and bamboo-like CNTs (Fig. 4-18 (e))	1.69		
J6	Catalyst-embedded carbon film and CNTs (Fig. 4-18 (f))	1.79		
J7	Catalyst-embedded carbon film (Fig. 4-18 (g))	1.83		

Table 4-4 Features of the carbon nanostructures and their properties (for $H_2/CH_4 = 0/1$ (sccm/sccm))

	The as-deposite	ed nanostructures			
Specimen designation	Length (nm)	Number density (G/inch ²)	Morphology		
K1			Catalysts particles (Fig. 4-19 (a))		
K2			Catalysts particles (Fig. 4-19 (b))		
K3			Catalysts particles (Fig. 4-19 (c))		
K4	42	30.4	Si nanostructures with ~42 nm height (Fig. 4-19 (d))		
K5	178	11.6	Si nanostructures with ~178 nm height (Fig. 4-19 (e))		
K6	254	6.0	Si nanostructures with ~254 nm height (Fig. 4-19 (f))		
L1			Catalyst film (Fig. 4-20 (a))		
L2			Catalysts particles (Fig. 4-20 (b))		
L3	72		Si nanostructures with ~72 nm height (Fig. 4-20 (c))		
L4	100	37.0	Si nanostructures with ~100 nm height (Fig. 4-20 (d))		
L5	158	10.2	Si nanostructures with ~158 nm height (Fig. 4-20 (e))		
L6	162	2 8 E S	Si nanostructures with ~162 nm height (Fig. 4-20 (f))		
M1			Catalysts particles with ~30nm diameter (Fig. 4-21 (a))		
M2		E 18	Catalysts particles with ~42nm diameter (Fig. 4-21 (b))		
M3		111-1	Catalysts particles with ~44nm diameter (Fig. 4-21 (c))		
M4	90	29.8	Si nanostructures with ~90 nm height (Fig. 4-21 (d))		
M5	114	6.4	Si nanostructures with ~114 nm height (Fig. 4-21 (e))		
M6	182	х	Si nanostructures with ~183 nm height (Fig. 4-21 (f))		

Table 4-5 Features of the nanostructures and their properties (for $H_2/CH_4 = 100/0$ (sccm/sccm))

x: The values could not be estimated.

		The post-treated				
с ·		nanostructures			E _{turn-on}	
Specimen	Post-treatment	Length	Morphology	I_D/I_G	$(V/\mu m)$	β
designation	condition	(CNCs + CNFs)			at 1 mA/cm ²	
		(nm)				
A5	Post1	385+93	CNFs on CNCs (Fig. 4-25 (a))	1.83		
			Trace CNFs on CNCs			
A5	Post2	358+x	(Fig. 4-25 (b))	2.28	~0.59	~19603
	D (2	212 0	Damaged CNCs, no CNFs	0.14		
A5	Post3	313+0	(Fig. 4-25 (c))	2.14		
	D 14	205.0	Damaged CNCs, no CNFs	1.04		
AS	Post4	285+0	(Fig. 4-25 (d))	1.94		
	D	757 0	Damaged CNCs, CNFs			
AS	Post5	/5/+0	(Fig. 4-25 (e))	1.95		
		00210	Damaged CNCs,CNFs	1.96		
AS	Posto	892+0	(Fig. 4-25(f))			
В5	Post1	697+0	CNCs (Fig. 4-26 (a))	1.79		
В5	Post2	571+0	CNCs (Fig. 4-26 (b))	1.87	~0.40	~18395
B5	Post3	429+0	Damaged CNCs (Fig. 4-26 (c))	2.28		
B5	Post4	256+0	Damaged CNCs (Fig. 4-26 (d))	2.08		
B5	Post5	519+0	Damaged CNCs (Fig. 4-26 (e))	2.10		
B5	Post6	Х	Damaged CNCs (Fig. 4-26 (f))	2.21		
C5	Post1	827+162	CNFs on CNCs (Fig. 4-27 (a))	2.21		
05	Post2		Damaged CNFs on CNCs	2.44	~0.81	~10061
65		/66+/9	(Fig. 4-27 (b))			
05	Post3	(70.0	Trace CNFs on damaged CNCs	2.23		
6		6/8+0	(Fig. 4-27 (c))			
05	D+4	527.0	Damaged CNCs, no CNFs	2.21		
6	POSt4	557+0	(Fig. 4-27 (d))			
C5	Deat5	062+0	Damaged CNCs, no CNFs (Fig.	2.22		
6	PUSID	902+0	(Fig. 4-27 (e))			
C5	Doctf	1617+0	Damaged CNCs, no CNFs (Fig.	2 22		
0	POSIO	101/+0	(Fig. 4-27 (f))	2.33		

Table 4-6 Features of the nanostructures and their properties (for Specimens A5, B5, and C5 after different H-plasma post-treatment times)

x: The values could not be estimated.

Specimen designation	Post-treatment condition	Morphology	I_D/I_G
H4	Post1	CNTs-embedded carbon film (Fig. 4-29(a))	1.39
H4	Post2	CNTs-embedded carbon film (Fig. 4-29(b))	1.48
H4	Post3	Short CNTs (Fig. 4-29(c))	1.17
H4	Post4	Damaged CNTs and Si nanocones (Fig. 4-29(d))	1.43
H4	Post5	Damaged CNTs and Si nanocones (Fig. 4-29(a))	1.52
H4	Post6	Damaged CNTs and Si nanocones (Fig. 4-29(f))	2.12
I4	Post1	CNTs-embedded carbon film (Fig. 4-30(a))	1.61
I4	Post2	Shorter CNTs (Fig. 4-30(b))	1.50
I4	Post3	Short CNTs (Fig. 4-30(c))	1.08
I4	Post4	Damaged CNTs and Si nanocones (Fig. 4-30(d))	1.35
I4	Post5	Damaged CNTs and Si nanocones (Fig. 4-30(e))	1.83
I4	Post6	Damaged CNTs and Si nanocones (Fig. 4-30(f))	2.09
J4	Post1	CNTs-embedded carbon film (Fig. 4-31(a))	1.54
J4	Post2	CNTs-embedded carbon film (Fig. 4-31(b))	1.47
J4	Post3	Damaged CNTs and Si nanocones (Fig. 4-31(c))	1.40
J4	Post4	Damaged CNTs and Si nanocones (Fig. 4-31(d))	1.42
J4	Post5	Damaged CNTs and Si nanocones (Fig. 4-31(e))	2.06
J4	Post6	Damaged CNTs and Si nanocones (Fig. 4-31(f))	2.27

Table 4-7 Features of the nanostructures and their properties (for Specimens H4, I4, andJ4 after different H-plasma post-treatment times)